I hereby certify that this correspondence is being deposited with the United States Postal Service) with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450:

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

Gottfried Ferber et al.

Applic. No.

: 10/056,770

Filed

: January 24, 2002

Title

: Semiconductor Module and Method for

Fabricating the Semiconductor Module

Examiner

: Long K. Tran

Group Art Unit: 2818

AMENDMENT

Hon. Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Responsive to the Office action dated March 26, 2003 kindly amend the above-identified application as follows:

ECHNOLOGY CENTER 2800